IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	)
Iwao HIGASHIKAWA	)
	)
Serial No.: Not yet assigned	) Group Art Unit:
	)
Filed: July 13, 2000	) Examiner:

For: PATTERN FORMING METHOD AND LIGHT EXPOSURE APPARATUS

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicant brings to the

Examiner's attention the document listed on attached Form PTO-1449. A copy of

the listed document is attached. Applicant respectfully requests that the Examiner

consider the document listed on attached Form PTO-1449 and indicate that it was

considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-

referenced application.

This submission does not represent that a search has been made or that

no better art exists and does not constitute an admission that the listed document

is material or constitutes "prior art." If the Examiner applies the document as prior

art against any claim in the application and applicant determines that the cited

document does not constitute "prior art" under United States law, applicant reserves the right to present to the office the relevant facts and law regarding the appropriate status of the document.
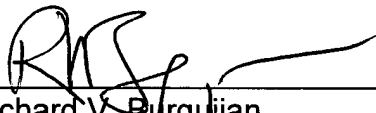
Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed document, should the document be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: Richard V. Burgujian
Reg. No. 31,744

Dated: July 13, 2000

Enclosures
RVB/FPD/rgm

LAW OFFICES
FINNEGAN, HENDERSON,
FARABOW, GARRETT,
& DUNNER, L.L.P.
1300 I STREET, N. W.
WASHINGTON, DC 20005
202-408-4000